



RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 2825

PATENT

Customer No. 22,852
Attorney Docket No. 2887.0259-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Junji SUGAMOTO et al.) Group Art Unit: 2891
Application No.: 10/706,090)
Filed: November 13, 2003) Examiner: LEE, Granvill D.
For: SEMICONDUCTOR WAFER)
TREATMENT METHOD,)
SEMICONDUCTOR WAFER)
INSPECTION METHOD,)
SEMICONDUCTOR DEVICE)
DEVELOPMENT METHOD AND)
SEMICONDUCTOR DEVICE)
TREATMENT APPARATUS)

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

REQUEST FOR RECONSIDERATION

In reply to the Final Office Action mailed March 23, 2005, the period for response to which having been extended through August 23, 2005, by a Petition for Extension of Two Months Time and fee payment filed concurrently herewith, Applicants respectfully request reconsideration of this application.

Remarks begin at page 2 of this paper.